

Second Call for Papers [MFEDK 2010]

The 2010 International Meeting for Future of Electron Devices, Kansai

May 13-14, 2010, Kansai University Centenary Memorial Hall, Osaka, Japan http://www.imfedk.org/

Conference Theme:

"Electron Devices for Future Safe and Comfortable Society"

General Chair

Yoichi Akasaka

Guest Professor & Former Professor of Osaka University

Executive Committee Chair

Tadashi Nishimura

Renesas Technology Corp.

Further Information

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Committee members

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Hiroyuki Fujii, KYOCERA Display Institute Co., Ltd.

Hideki Hayashi, Sumitomo Electric Corp.
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Naoto Matsuo, University of Hyogo
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Shinji Odanaka, Osaka University
Matsuo Ogawa, Kobe University
Yasuhisa Omura, Kansai University
Hirokyki Sakai, Panasonic Corp.

Shigehiko Sasa, Osaka Institute of Technology

Tomonori Seki, OMRON Corp. Akira Takahashi, SHARP Corp.

Yukiharu Uraoka, Nara Institute of Science and Technology

Hirobumi Watanabe, Ricoh Co., Ltd.

Masahiro Yoshimoto, Kyoto Institute of Technology



IMFEDK

The meeting covers all areas of electron devices: Si-devices, compound semiconductor devices, emerging solid-state devices, and related modeling, simulation, characterization, material & process technologies.

Location

Osaka is one of the best sightseeing spots in Japan. Detailed access map to Kansai University Centenary Memorial Hall is available at

http://www.kansai-u.ac.jp/global/guide/mapsenri.html http://www.kansai-u.ac.jp/English/about_ku/senri_map.html

Official Language

English will be used for all printed materials, presentation and discussion, except tutorials.

Paper Submission

Submission will be received from Jan. 5 through **Feb. 3, 2010**. Result of paper selection will be sent to the author by the end of Feb.

IEEE EDS Kansai Chapter IMFEDK Awards

(Best Paper, Student Paper)

The IMFEDK Awards will be awarded to the excellent papers written and presented by IEEE members. Only the first author, in the case of Student Paper Award, is honored with

testimonials during the IMFEDK Meeting.